

Electronic Acknowledgement Receipt

EFS ID:	1041375
Application Number:	10615794
Confirmation Number:	3511
Title of Invention:	Void-free damascene copper deposition process and means of monitoring thereof
First Named Inventor:	Panayotis Andricacos
Customer Number:	30678
Filer:	John A. Evans/Lisa Hawkins
Filer Authorized By:	John A. Evans
Attorney Docket Number:	20140-00302-US /YOR920030
Receipt Date:	08-MAY-2006
Filing Date:	10-JUL-2003
Time Stamp:	16:02:17
Application Type:	Utility
International Application Number:	

Payment information:

Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1		20140-302-US-050806Amd.pdf	116174	yes	8

	Multipart Description		
	Doc Desc	Start	End
	Amendment After Final	1	1
	Claims	2	4
	Applicant Arguments/Remarks Made in an Amendment	5	8
Warnings:			
Information:			
Total Files Size (in bytes):		116174	
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